

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi OKUBO et al.

Application No.: 10/551,136

Filed: January 5, 2006



Group Art Unit: 1795

Examiner: S. ROSASCO

Docket No.: 125493

For: MASK BLANK, MANUFACTURING  
METHOD OF MASK BLANK,  
MANUFACTURING METHOD OF  
TRANSFER MASK AND MANUFACTURING  
METHOD OF SEMICONDUCTOR DEVICE

**MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

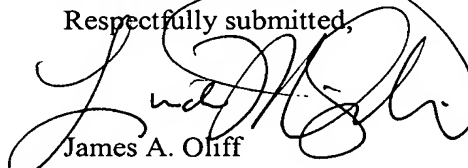
In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

☒ Applicants further request entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 225792 in the amount of \$810.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated for this filing to Deposit Account No. 15-0461

Respectfully submitted,



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JAO:JSP/jfb

Date: January 15, 2010

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**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry of this filing;  
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